

PATENT / DOCKET NO. 2002.0405/24061.486  
CUSTOMER NO. 000042717



JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Baw-Ching Perng, et al.

Serial No.: 10/766,596

Filed: January 27, 2004

For: ZIRCONIUM OXIDE AND  
HAFNIUM OXIDE ETCHING  
USING HALOGEN CONTAINING  
CHEMICALS

§ Attorney Docket No.  
§ 2002.0405 / 24061.486  
§  
§ Customer No. 42717  
§  
§ Group Art Unit: 2813  
§  
§ Examiner: Thanhha S. Pham  
§  
§ Confirmation No.: 3425  
§

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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Kelly A. Morau  
Signature of person mailing paper and fee

AMENDMENT

This Amendment is submitted in reply to the Office Action mailed on January 26, 2005.  
(Please see the pages that follow).

02/24/2005 RFEKADU1 00000018 10766596

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